

PERSONNEL  
DEPARTMENT


राष्ट्रीय प्रौद्योगिकी संस्थान श्रीनगर  
**NATIONAL INSTITUTE OF TECHNOLOGY SRINAGAR**  
(An autonomous Institute of National Importance under the aegis of  
Ministry of Education, Govt. of India)  
हजरतबल, श्रीनगर, जम्मू-कश्मीर, 190006, भारत  
Hazratbal, Srinagar Jammu and Kashmir, 190006, INDIA



**ORDER NO: 9 of 2021**

**Dated: 17/12/2020**

Based on recommendations of CRFC Committee and pursuant to approval of the Competent Authority, the usage charges of CRFC facilities are hereby revised as detailed in Annexure- A enclosed.

  
2/1/21  
Registrar  
01/01/21

No: NIT/PD/21/86-91

Date: 04/01/2021

Copy To:

1. Prof. M. F. Wani, Chairman CRFC
2. Committee Members
3. Deputy Registrar (Accounts)
4. Assistant Registrar (Audit)
5. P.A. to Director for kind information of the Director.
6. Concerned File.
7. General Order File.



# NATIONAL INSTITUTE OF TECHNOLOGY SRINAGAR

(An Autonomous Institute of National Importance Established by the Act of Parliament)

## OFFICE OF THE CHAIRMAN CRFC

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Website: <http://new.nitsri.ac.in> Email: [crfc@nitsri.net](mailto:crfc@nitsri.net)

### Annexure A

S.no.	Equipment	Usage Charges (in INR)							
		For NIT Users		For Project work of NIT users		For other academic institutes		Industries/private laboratories	
1.	i) XRD (Simple phase analysis)	200/Sample		300/Sample		300/Sample		1000/Sample	
	ii) Thin Film Analysis	300/ Sample		500/Sample		500/Sample		1500/Sample	
	iii) SAXS	500/Sample		500/Sample		700/Sample		2000/Sample	
2.	CHN and Oxygen Estimation	600/sample		700/sample		800/sample		2000/sample	
3.	Raman Spectroscopy	200/Sample		300/Sample		300/Sample		400/Sample	
4.	Zeta potential and Particle Analyzer	200/Sample		300/Sample		300/Sample		400/Sample	
5.	Rheometer	100/Sample		200/Sample		200/Sample		350/Sample	
6.	Planetary ball mill	50/Hour		150/Hour		150/Hour		250/Hour	
7.	Thermal analyzer (TGA/DSC)	200/Sample		300/Sample		300/Sample		400/Sample	
8.	Nano mechanical system-TI Premier Dynamic system	Indentation	100/sample/test	Indentation	200/sample/test	Indentation	200/sample/test	Indentation	300/sample/test
		Scratch	200/Sample/test	Scratch	300/Sample/test	Scratch	300/Sample/test	Scratch	400/Sample/test
9.	Scanning Electron Microscope (SEM)	250/Sample		500/Sample		500/Sample		1000/Sample	
10.	FESEM	With Coating	Without Coating	With Coating	Without Coating	With Coating	Without Coating	With Coating	Without Coating
		500/Sample/exposure	300/Sample/exposure	1000/Sample/exposure	800/Sample/exposure	1200/Sample/exposure	800/Sample/exposure	2000/Sample/exposure	1000/Sample/exposure
11.	Multi Target Sputtering System	3000/Sample + Target		4000/Sample + Target		5000/Sample +Target		6000/Sample +Target	